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PATENT

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October 5, 2001
Date

Ayesha S. Wilks
Ayesha S. Wilks

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Vishnu K. Agarwal
Serial No. : 09/652,841
Filed : August 31, 2000
Title : DEVICE AND METHOD FOR PROTECTING AGAINST OXIDATION OF CONDUCTIVE LAYER IN SAID DEVICE

Attorney Docket No.: 501082.03 (98-0616.02)
Group Art Unit : 2815
Examiner : Jose R. Diaz

Commissioner of Patents
Washington, DC 20231

AMENDMENT

Sir:

Applicant acknowledge receipt of the Office Action dated April 12, 2001, and herewith petitions the Commissioner of Patents under 37 C.F.R. § 1.136(a)(3) for a 3-month extension of time for filing this response from July 12, 2001, to October 12, 2001. Submitted herewith is a check in the amount of \$1088, which includes \$920 to cover the cost of the extension. Any deficiency or overpayment should be charged or credited to Deposit Account No. 50-1266.

In the Claims:

Please amend claim 1 as follows:

1. (Amended) A method of treating a semiconductor device, comprising:
providing a capacitor having a first plate, a dielectric over said first plate,
and a second plate over said dielectric, the second plate including first and second conductive layers;

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01 FC:117 920.00 OP

10/12/2001 HVUONG1 00000106 09652841

02 FC:102 168.00 OP